

IWAD and the 14th RD51 Collaboration Meeting

Wednesday, 29 October 2014

WG6 - Production (10:10 - 13:30)

-Conveners: Fabien Jeanneau; Rui De Oliveira

time	[id] title	presenter
10:10	[1] Tech-etch GEM production status	SURROW, Bernd
10:30	[2] GEM foil development at ECIL (presented by S.Nagarajan)	DUBEY, Anand Kumar
10:50	[3] Single mask GEM foil development in India (presented by P.Menon)	PANT, Lalit
11:10	coffee break	
11:50	[4] GEM foils quality control from high resolution images	GUTIERREZ, Rafael M
12:10	[5] Dry process for GEM foil fabrication (presented by A.Joshi)	PANT, Lalit
12:30	[6] Gem production at Techtra	BIELOWKA, Piotr
12:50	[7] GEM and Micromegas standard detectors	FRANCHINO, Silvia
13:10	discussion	